

PTO/SB/08 Equivalent

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Multiple sheets used when necessary)

SHEET 1 OF 15

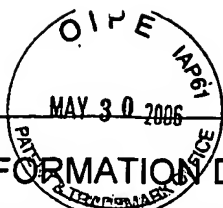
Application No.	10/807,129
Filing Date	March 24, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
EAL	1.	2,534,846	12/19/50	Ambrose et al.	
	2.	2001/0026951	10/04/01	Vergani et al.	
	3.	2001/0040675	11/15/01	True et al.	
	4.	20010003487	06/14/01	Miles	
	5.	20010040649	11/15/01	Ozaki	
	6.	2002/015215	02/07/02	Miles	
	7.	2002/036304	03/28/02	Ehmke et al.	
	8.	2002/054424	5/9/2002	Miles	
	9.	2002/055253	05/09/02	Rudhard	
	10.	2002/137072	09/26/02	Mirkin et al.	
	11.	2002/168136	11/14/02	Atia et al.	
	12.	20020015215	02/07/02	Miles	
	13.	20020071169	06/13/02	Bowers et al.	
	14.	20020075555	06/20/02	Miles	
	15.	20020126364	09/12/02	Miles	
	16.	2002/0135857	09/26/02	Fitzpatrick et al.	
	17.	2002/138213	07/24/2003	Jin et al.	
	18.	2003/0006468	01/09/03	Ma et al.	
	19.	2003/0090350	05/15/03	Feng et al.	
	20.	20030043157	03/06/03	Miles	
	21.	20030062186	04/03/03	Boroson et al.	
	22.	20030072070	04/17/03	Miles	
	23.	20030152872	08/14/03	Miles, Mark W.	
	24.	20030202264	10/30/03	Weber et al.	
	25.	20030202265	10/30/03	Reboa et al.	
	26.	20030202266	10/30/03	Ring et al.	
	27.	2003/112096	06/19/2003	Potter Michael D.	
	28.	2004/0100677	05/27/04	Huibers et al.	
	29.	2004/010115	01/15/04	Sotzing	
	30.	2004/0124073	07/2004	Pilans et al.	
	31.	2004/0125281	07/01/04	Lin et al.	
	32.	2004/136076	07/15/2004	Tayebati Parviz	
EAL	33.	2004/0145811	07/29/04	Lin et al.	

Examiner Signature	/Evelyn Lester/	Date Considered	09/18/2006
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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SHEET 2 OF 15

Application No. 10/807,129

Filing Date March 24, 2004

First Named Inventor Wen-Jian Lin

Art Unit 2873

Examiner LESTER, EVELYN A

Attorney Docket No. QCO.087A / 061119

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
EAL	34.	2004/0147198	07/29/04	Lin et al.	
	35.	2004/0175577	09/09/04	Lin et al.	
	36.	2004/0191937	09/30/04	Patel et al.	
	37.	2004/0207897	10/21/04	Lin	
EAL	38.	2004/0209192	10/21/04	Lin et al.	
	39.	2004/0209195	10/21/04	Lin	cited on PTO-892
EAL	40.	2004/0240027	12/02/04	Lin et al.	
	41.	2004/027636	02/12/04	Miles	
	42.	2004/027701	2/12/2004	Ishikawa	
	43.	2004/051929	03/18/04	Sampsel et al.	
	44.	2004/053434	03/18/04	Bruner	
	45.	2004/058532	03/25/04	Miles et al.	
	46.	2004/063322	04/01/2004	Yang	
	47.	2004/125282	7/1/2004	Lin et al.	
	48.	20040028849	02/12/04	Stark et al.	
	49.	20040035821	02/26/04	Doan et al.	
	50.	20040051929	03/18/04	Sampsel et al.	
	51.	20040058532	03/25/04	Miles et al.	
	52.	20040061543	04/01/04	Nam et al.	
	53.	20040080807	04/29/04	Chen et al.	
	54.	2004/080832	04/29/2004	Singh Mandeep	
	55.	20040145049	07/29/04	McKinnell et al.	
	56.	20040147056	07/29/04	McKinnell et al.	
	57.	20040150869	08/05/04	Kasai, Hiroto	
	58.	20040160143	08/19/04	Shreeve et al.	
	59.	20040174583	09/09/04	Chen et al.	
	60.	20040179281	09/16/04	Reboa	
	61.	20040212026	10/28/04	Van Brocklin et al.	
	62.	20040217378	11/04/04	Martin et al.	
	63.	20040217919	11/04/04	Pichl et al.	
	64.	20040218251	11/04/04	Pichl et al.	
	65.	20040218334	11/04/04	Martin et al.	
	66.	20040218341	11/04/04	Martin et al.	
EAL	67.	20040227493	11/18/04	Van Brocklin et al.	

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Date Considered 09/18/2006

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SHEET 3 OF 15

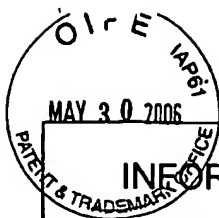
Application No.	10/807,129
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First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

U.S. PATENT DOCUMENTS

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EAL	68.	20040240032	12/02/04	Miles	
↓	69.	20040240138	12/02/04	Martin et al.	
↓	70.	20040245588	12/09/04	Nikkell et al.	
↓	71.	20040263944	12/30/04	Miles et al.	
↓	72.	2005/0003667	01/06/05	Lin et al.	
EAL	73.	2005/0020089	01/27/05	Shi et al.	
↓	74.	2005/0024667	02/03/05	Lin	cited on PTO-892
EAL	75.	2005/0035699	02/17/05	Tsai	
↓	76.	2005/0036095	02/17/05	Yeh et al.	
↓	77.	2005/0036192	02/17/05	Lin et al.	
↓	78.	2005/0042117	02/24/05	Lin	
↓	79.	2005/0046922	03/03/05	Lin et al.	
↓	80.	2005/0046948	03/03/05	Lin	
↓	81.	2005/0068605	03/31/05	Tsai	
EAL	82.	2005/0068606	03/31/05	Tsai	
↓	83.	2005/0078348	04/14/05	Lin	cited on PTO-892
↓	84.	2005/0168849	08/04/05	Lin	cited on PTO-892
EAL	85.	2005/0195462	09/08/05	Lin	
↓	86.	2005/0202649	09/15/05	Hung et al.	
↓	87.	20050001828	01/06/05	Martin et al.	
↓	88.	20050038950	02/17/05	Adelmann	
↓	89.	20050057442	03/17/05	Way	
↓	90.	20050068583	03/31/05	Gutkowski et al.	
↓	91.	20050069209	03/31/05	Damera-Venkata et al.	
↓	92.	3,439,973	04/22/69	Paul et al.	
↓	93.	3,443,854	05/13/69	Weiss	
↓	94.	3,653,741	04/04/72	Marks	
↓	95.	3,656,836	04/18/72	de Cremoux et al.	
↓	96.	3,725,868	04/03/73	Malmer, Jr. et al.	
↓	97.	3,813,265	05/28/74	Marks	
↓	98.	3,955,880	05/11/76	Lierke	
↓	99.	4,099,854	07/11/78	Decker et al.	
↓	100.	4,196,396	04/01/80	Smith	
EAL	101.	4,228,437	10/14/80	Shelton	

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**INFORMATION DISCLOSURE
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SHEET 4 OF 15

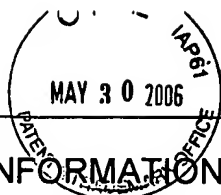
Application No.	10/807,129
Filing Date	March 24, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
EAL	102.	4,377,324	03/22/83	Durand et al.	
	103.	4,389,096	06/21/83	Hori et al.	
	104.	4,403,248	09/06/83	te Velde	
	105.	4,441,791	04/10/84	Hombeck	
	106.	4,445,050	04/24/84	Marks	
	107.	4,459,182	07/10/84	te Velde	
	108.	4,482,213	11/13/84	Piliavin et al.	
	109.	4,500,171	02/19/85	Penz et al.	
	110.	4,519,676	05/28/85	te Velde	
	111.	4,531,126	07/23/85	Sadones	
	112.	4,566,935	01/28/86	Hombeck	
	113.	4,571,603	02/18/86	Hombeck et al.	
	114.	4,596,992	06/24/86	Hombeck	
	115.	4,615,595	10/07/86	Hombeck	
	116.	4,662,746	05/05/87	Hombeck	
	117.	4,663,083	05/05/87	Marks	
	118.	4,681,403	07/21/87	te Velde et al.	
	119.	4,710,732	12/01/87	Hombeck	
	120.	4,748,366	05/31/88	Taylor	
	121.	4,786,128	11/22/88	Birnbach	
	122.	4,790,635	12/13/88	Apsley	
	123.	4,856,863	08/15/89	Sampsell et al.	
	124.	4,937,496	06/26/90	Neiger et al.	
	125.	4,954,789	09/04/90	Sampsell	
	126.	4,956,619	09/11/90	Hombeck	
	127.	4,982,184	01/01/91	Kirkwood	
	128.	5,018,256	05/28/91	Hombeck	
	129.	5,022,745	06/11/91	Zahowski et al.	
	130.	5,028,939	07/02/91	Hombeck et al.	
	131.	5,037,173	08/06/91	Sampsell et al.	
	132.	5,044,736	09/03/91	Jaskie et al.	
	133.	5,061,049	10/29/91	Hombeck	
	134.	5,075,796	12/24/91	Schildkraut et al.	
EAL	135.	5,078,479	01/07/92	Vuilleumier	

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SHEET 5 OF 15

Application No.	10/807,129
Filing Date	March 24, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

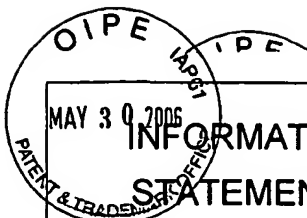
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Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
EAL	136.	5,079,544	01/07/92	DeMond et al.	
	137.	5,083,857	01/28/92	Hornbeck	
	138.	5,096,279	03/17/92	Hornbeck et al.	
	139.	5,099,353	03/24/92	Hornbeck	
	140.	5,124,834	06/23/92	Cusano et al.	
	141.	5,136,669	08/04/92	Gerd	
	142.	5,142,405	08/25/92	Hornbeck	
	143.	5,142,414	08/25/92	Kochler	
	144.	5,153,771	10/06/92	Link et al.	
	145.	5,162,787	11/10/92	Thompson et al.	
	146.	5,168,406	12/01/92	Nelson	
	147.	5,170,156	12/08/92	DeMond et al.	
	148.	5,172,262	12/15/92	Hornbeck	
	149.	5,179,274	01/12/93	Sampsell	
	150.	5,192,395	03/09/93	Boysel et al.	
	151.	5,192,946	03/09/93	Thompson et al.	
	152.	5,206,629	04/27/93	DeMond et al.	
	153.	5,214,419	05/25/93	DeMond et al.	
	154.	5,214,420	05/25/93	Thompson et al.	
	155.	5,216,537	06/01/93	Hornbeck	
	156.	5,226,099	07/06/93	Mignardi et al.	
	157.	5,228,013	07/13/93	Bik	
	158.	5,231,532	07/27/93	Magel et al.	
	159.	5,233,385	08/03/93	Sampsell	
	160.	5,233,456	08/03/93	Nelson	
	161.	5,233,459	08/03/93	Bozler et al.	
	162.	5,254,980	10/19/93	Hendrix et al.	
	163.	5,272,473	12/21/93	Thompson et al.	
	164.	5,278,652	01/11/94	Urbanus et al.	
	165.	5,280,277	01/18/94	Hornbeck	
	166.	5,287,096	02/15/94	Thompson et al.	
	167.	5,296,950	03/22/94	Lin et al.	
	168.	5,299,041	03/29/94	Morin et al.	
EAL	169.	5,305,640	04/26/94	Boysel et al.	

Examiner Signature	/Evelyn Lester/	Date Considered	09/18/2006
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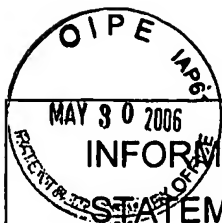
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INFORMATION DISCLOSURE STATEMENT BY APPLICANT (Multiple sheets used when necessary) SHEET 6 OF 15	Application No.	10/807,129
	Filing Date	March 24, 2004
	First Named Inventor	Wen-Jian Lin
	Art Unit	2873
	Examiner	LESTER, EVELYN A
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EAL	170.	5,311,360	05/10/94	Bloom et al.	
	171.	5,312,513	05/17/94	Florence et al.	
	172.	5,323,002	06/21/94	Sampsell et al.	
	173.	5,324,683	06/28/94	Fitch et al.	
	174.	5,325,116	06/28/94	Sampsell	
	175.	5,326,430	07/05/94	Cronin et al.	
	176.	5,327,286	07/05/94	Sampsell et al.	
	177.	5,331,454	07/19/94	Hombeck	
	178.	5,339,116	08/16/94	Urbanus et al.	
	179.	5,345,328	09/06/94	Fritz et al.	
	180.	5,365,283	11/15/94	Doherty et al.	
	181.	5,381,232	01/10/95	van Wijk	
	182.	5,381,253	01/10/95	Sharp et al.	
	183.	5,401,983	03/28/95	Jokerst et al.	
	184.	5,411,769	05/02/95	Hombeck	
	185.	5,444,566	08/22/95	Gale et al.	
	186.	5,446,479	08/29/95	Thompson et al.	
	187.	5,448,314	09/05/95	Heimbuch et al.	
	188.	5,452,024	09/19/95	Sampsell	
	189.	5,454,906	10/03/95	Baker et al.	
	190.	5,457,493	10/10/95	Leddy et al.	
	191.	5,457,566	10/10/95	Sampsell et al.	
	192.	5,459,602	10/17/95	Sampsell	
	193.	5,459,610	10/17/95	Bloom et al.	
	194.	5,461,411	10/24/95	Florence et al.	
	195.	5,489,952	02/06/96	Gove et al.	
	196.	5,497,172	03/05/96	Doherty et al.	
	197.	5,497,197	03/05/96	Gove et al.	
	198.	5,499,062	03/12/96	Urbanus	
EAL	199.	5,500,635	03/19/96	Mott	
	200.	5,500,761	03/19/96	Goossen et al.	cited on PTO-892
EAL	201.	5,503,952	04/02/96	Suzuki et al.	
EAL	202.	5,506,597	04/09/96	Thompson et al.	
EAL	203.	5,515,076	05/07/96	Thompson et al.	

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	Art Unit	2873
SHEET 7 OF 15		Examiner LESTER, EVELYN A
		Attorney Docket No. QCO.087A / 061119

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Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
EAL	204.	5,517,347	05/14/96	Sampsell	
	205.	5,523,803	06/04/96	Urbanus et al.	
	206.	5,526,051	06/11/96	Gove et al.	
	207.	5,526,172	06/11/96	Kanack	
	208.	5,526,327	06/11/96	Cordova, Jr.	
	209.	5,526,688	06/18/96	Boysel et al.	
	210.	5,535,047	07/09/96	Hombeck	
	211.	5,548,301	08/20/96	Komher et al.	
	212.	5,551,293	09/03/96	Boysel et al.	
	213.	5,552,924	09/03/96	Tregilgas	
	214.	5,552,925	09/03/96	Worley	
	215.	5,559,358	09/24/96	Burns et al.	
	216.	5,563,398	10/08/96	Sampsell	
	217.	5,567,334	10/22/96	Baker et al.	
	218.	5,570,135	10/29/96	Gove et al.	
	219.	5,579,149	11/26/96	Moret et al.	
	220.	5,581,272	12/03/96	Conner et al.	
	221.	5,583,688	12/10/96	Hombeck	
	222.	5,589,852	12/31/96	Thompson et al.	
	223.	5,597,736	01/28/97	Sampsell	
	224.	5,600,383	02/04/97	Hombeck	
	225.	5,602,671	02/11/97	Hombeck	
	226.	5,606,441	02/25/97	Florence et al.	
	227.	5,608,468	03/04/97	Gove et al.	
	228.	5,610,438	03/11/97	Wallace et al.	
	229.	5,610,624	03/11/97	Bhuva	
	230.	5,610,625	03/11/97	Sampsell	
	231.	5,619,059	04/08/97	Li et al.	
	232.	5,619,365	04/08/97	Rhoades et al.	
	233.	5,619,366	04/08/97	Rhoads et al.	
	234.	5,622,814	04/22/97	Miyata et al.	
	235.	5,629,790	05/13/97	Neukermans et al.	
	236.	5,633,652	05/27/97	Kanbe et al.	
	237.	5,636,052	06/03/97	Arney et al.	

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SHEET 8 OF 15

Application No.	10/807,129
Filing Date	March 24, 2004
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Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

U.S. PATENT DOCUMENTS

Examiner Initials	Cite No.	Document Number Number - Kind Code (if known) Example: 1,234,567 B1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear
EAL	238.	5,636,185	06/03/97	Brewer et al.	
↓	239.	5,638,084	06/10/97	Kalt	
↓	240.	5,638,946	06/17/97	Zavracky	
↓	241.	5,641,391	06/24/97	Hunter et al.	
↓	242.	5,646,768	07/08/97	Kaciyama	
↓	243.	5,650,881	07/22/97	Hornbeck	
↓	244.	5,654,741	08/05/97	Sampsell et al.	
↓	245.	5,657,099	08/12/97	Doherty et al.	
↓	246.	5,659,374	08/19/97	Gale, Jr. et al.	
↓	247.	5,665,997	09/09/97	Weaver et al.	
↓	248.	5,673,139	09/30/97	Johnson	
↓	249.	5,674,757	10/07/97	Kim	
↓	250.	5,683,591	11/04/97	Offenberg	
↓	251.	5,703,710	12/30/97	Brinkman et al.	
↓	252.	5,706,022	01/06/98	Hato	
↓	253.	5,710,656	01/20/98	Goosen	
EAL	254.	5,726,480	03/10/98	Pister	
↓	255.	5,739,943	04/14/98	Payebadi	cited on PTO-892
EAL	256.	5,745,193	04/28/98	Urbanus et al.	
↓	257.	5,745,281	04/28/98	Yi et al.	
↓	258.	5,771,116	06/23/98	Miller et al.	
↓	259.	5,784,190	07/21/98	Worley	
↓	260.	5,784,212	07/21/98	Hornbeck	
↓	261.	5,793,504	08/11/98	Stoll	
↓	262.	5,808,780	09/15/98	McDonald	
↓	263.	5,818,095	10/06/98	Sampsell	
EAL	264.	5,825,528	10/20/98	Goosen	
↓	265.	5,835,255	11/10/98	Miles	cited previous PTO-1449
EAL	266.	5,842,088	11/24/98	Thompson	
↓	267.	5,867,302	02/02/99	Fleming et al.	
↓	268.	5,912,758	06/15/99	Knipe et al.	
↓	269.	5,943,158	08/24/99	Ford et al.	
↓	270.	5,959,763	09/28/99	Bozler et al.	
EAL	271.	5,986,796	11/16/99	Miles	

Examiner Signature	/Evelyn Lester/	Date Considered	09/18/2006
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PTO/SB/08 Equivalent

INFORMATION DISCLOSURE STATEMENT BY APPLICANT

(Multiple sheets used when necessary)

SHEET 10 OF 15

Application No.	10/807,129
Filing Date	March 24, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

U.S. PATENT DOCUMENTS

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EAL	306.	6,466,354	10/15/02	Gudeman	
	307.	6,466,358	10/15/02	Tew	
	308.	6,473,274	10/29/02	Maimone et al.	
	309.	6,480,177	11/12/02	Doherty et al.	
	310.	6,496,122	12/17/02	Sampsell	
	311.	6,513,911	02/2003	Ozaki et al.	
	312.	6,545,335	04/08/03	Chua et al.	
	313.	6,548,908	04/15/03	Chua et al.	
	314.	6,549,338	04/15/03	Wolverton et al.	
	315.	6,552,840	04/22/03	Knipe	
	316.	6,574,033	06/03/03	Chui et al.	
	317.	6,589,625	07/08/03	Kothari et al.	
	318.	6,600,201	07/29/03	Hartwell et al.	
	319.	6,606,175	08/12/03	Sampsell et al.	
	320.	6,608,268	08/19/03	Goldsmith	
	321.	6,625,047	09/23/03	Coleman, Jr., deceased	
	322.	6,630,786	10/07/03	Cummings et al.	
	323.	6,632,698	10/14/03	Ives	
	324.	6,635,919	10/21/03	Melendez et al.	
	325.	6,643,069	11/04/03	Dewald	
	326.	6,650,455	11/18/03	Miles, Mark W.	
	327.	6,657,832	12/02/03	Williams et al.	
	328.	6,666,561	12/23/03	Blakley	
	329.	6,674,562	01/06/04	Miles et al.	
	330.	6,680,792	01/20/04	Miles	
	331.	6,710,908	03/23/04	Miles et al.	
	332.	6,720,267	04/13/04	Chen et al.	
	333.	6,736,987	05/18/04	Cho	
	334.	6,741,377	05/25/04	Miles	
	335.	6,741,384	05/25/04	Martin et al.	
	336.	6,741,503	05/25/04	Farris et al.	
	337.	6,743,570	06/01/04	Harnett et al.	
EAL	338.	6,747,785	06/08/04	Chen et al.	
	339.	6,747,888	06/08/04	Lin	cited on PTO-892

Examiner Signature

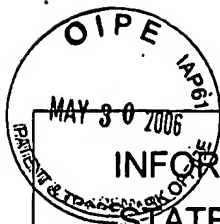
/Evelyn Lester/

Date Considered

09/18/2006

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INFORMATION DISCLOSURE STATEMENT BY APPLICANT

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SHEET 11 OF 15

Application No.	10/807,129
Filing Date	March 24, 2004
First Named Inventor	Wen-Jian Lin
Art Unit	2873
Examiner	LESTER, EVELYN A
Attorney Docket No.	QCO.087A / 061119

U.S. PATENT DOCUMENTS

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EAL	340.	6,756,317	06/29/04	Sniegowski, et al.	
	341.	6,768,097	07/27/04	Viktorovitch et al.	
	342.	6,775,174	08/10/04	Huffman et al.	
	343.	6,778,155	08/17/04	Doherty et al.	
	344.	6,778,306	08/17/04	Sniegowski, et al.	
	345.	6,794,119	09/21/04	Miles	
	346.	6,811,267	11/02/04	Allen et al.	
	347.	6,812,482	11-02-2004	Fleming, et al.	
	348.	6,819,469	11/16/04	Koba	
	349.	6,822,628	11/23/04	Dunphy et al.	
	350.	6,829,132	12/07/04	Martin et al.	
	351.	6,853,129	02/08/05	Cummings et al.	
	352.	6,855,610	02/15/05	Tung et al.	
	353.	6,859,218	02/22/05	Luman et al.	
	354.	6,861,277	03/01/05	Monroe et al.	
	355.	6,862,022	03/01/05	Slupe	
	356.	6,862,029	03/01/05	D'Souza et al.	
	357.	6,867,896	03/15/05	Miles	
	358.	6,870,581	03/22/05	Li et al.	
	359.	6,870,654	03/22/05	Lin et al.	
EAL	360.	6,882,458	04/19/05	Lin et al.	
	361.	6,882,461	04/19/05	Lin et al.	cited on PTO-892
	362.	6,912,033	06/08/05	Lin et al.	cited on PTO-892
EAL	363.	6,952,303	10/04/05	Lin et al.	
	364.	6,958,847	10/25/05	Lin	cited on PTO-892

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Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
EAL	365.	CH 681 047	12-31-1992	Landis & GYR Betriebs AG		
EAL	366.	DE 10228946 A1	1/22/2004	Universitat Bremen		
EAL	367.	EP 0 667 548 A1	08-16-1995	AT&T Corporation		
EAL	368.	EP 0 878 824 A2	11/18/1998	Surface Technology Systems Limited		

Examiner Signature	/Evelyn Lester/	Date Considered	09/18/2006
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	Filing Date	March 24, 2004	
	First Named Inventor	Wen-Jian Lin	
	Art Unit	2873	
(Multiple sheets used when necessary)		Examiner	LESTER, EVELYN A
SHEET 12 OF 15		Attorney Docket No.	QCO.087A / 061119

FOREIGN PATENT DOCUMENTS						
Examiner Initials	Cite No.	Foreign Patent Document Country Code-Number-Kind Code Example: JP 1234567 A1	Publication Date MM-DD-YYYY	Name of Patentee or Applicant	Pages, Columns, Lines Where Relevant Passages or Relevant Figures Appear	T ¹
EAL	369.	EP 0 694 801	01/31/1996	Texas Instruments Incorporated		
	370.	EP 1 452 481 A	9/1/2004	Dalsa Semiconductor Inc.		
	371.	EP 1 197 778	04/17/2002	Agere Systems Guardian Corp. & Lucent Technologies Inc.		
	372.	EP 0 695 959	02/07/1996	AT&T CORP.		
	373.	JP 05275401 A1	10-22-1993	Yokogawa Electric Corporation		
	374.	JP 2002 062493	2/28/2002	Canon Inc.		
	375.	JP 2003001598 A	1/8/2003	Sony Corp		
	376.	JP 2004106074 A	4/8/2004	Sony Corp		
	377.	JP 2005051007 A	2/24/2005	Tokyo Electron Ltd.		
	378.	WO 02/24570	03-28-2002	Marconi Caswell Ltd.		
	379.	WO 03/069413 A	8/21/2003	Iridigm Display Corporation		
	380.	WO 2005/019899 A1	3/3/2005	Iridigm Display Corporation		
	381.	WO0114248	03-01-2001	Knowles Electronics, LLC		
	382.	WO03007049A1	01-23-2003	Iridigm Display Corp.		
	383.	WO 03052506	06/26/2003	Nokia Corp., Aeyrales, Pekka, Tammela, & Simo.		
	384.	WO03069413A1	08-21-2003	Iridigm Display Corp.		
	385.	WO03073151A1	09-04-2003	Iridigm Display Corp.		
	386.	WO04006003A1	01-15-2004	Iridigm Display Corp.		
	387.	WO04026757A2	04-01-2004	Iridigm Display Corp.		
	388.	WO9530924	11-16-1995	Etalon, Inc.		
	389.	WO9717628	05-15-1997	Etalon, Inc.		
	390.	WO9952006A2	10-14-1999	Etalon, Inc.		
EAL	391.	WO9952006A3	10-14-1999	Etalon, Inc.		

NON PATENT LITERATURE DOCUMENTS			
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EAL	392.	AKASAKA, "Three-Dimensional IC Trends," Proceedings of IEEE, vol. 74, No. 12, pp. 1703-1714, (Dec. 1986).	

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	Art Unit	2873	
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SHEET 13 OF 15		Attorney Docket No.	QCO.087A / 061119

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EAL	393.	Austrian Search Report dated May 4, 2005	
	394.	Austrian Search Report dated August 12, 2005	
	395.	ARATANI K. ET AL>, "Process and Design Considerations for Surface Micromachined Beams for a Tuneable Interferometer Array in Silicon," Proceedings of the Workshop on Micro Electro Mechanical Systems (MEMS) Fort Lauderdale, Feb. 7-10, 1993, New York, IEEE, US, vol. Workshop 6, 7 February 1993, pages 230-235	
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	403.	GOOSSEN K.W., "MEMS-BASED VARIABLE OPTICAL INTERFERENCE DEVICES", OPTICAL MEMS, 200 IEEE/Leos International Conference on August 21-24, 2000, Piscataway, NJ, USA, IEE, August 21, 2000, pages 17-18	
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	406.	HOWARD et al., "Nanometer-Scale Fabrication Techniques," VLSI Electronics: Microstructure Science, vol. 5 pp. 145-153 and pp. 166-173 (1982).	
	407.	IBBOTSON et al., "Comparison of XeF2 and Fatom reactions with Si and SiO2," Applied Physics Letters, vol. 44, No. 12, pp. 1129-1131 (Jun. 1984).	
	408.	JACKSON "Classical Electrodynamics," John Wiley & Sons Inc., pp.568-573. (date unknown).	
	409.	JERMAN et al., "A Miniature Fabry-Perot Interferometer with a Corrugated Silicon Diaphragm Support," (1988).	
	410.	JOANNOPOULOS et al., "Photonic Crystals: Molding the Flow of Light," Princeton University Press (1995).	
EAL	411.	JOHNSON, "Optical Scanners," Microwave Scanning Antennas, vol. 1, p. 251-261, (1964).	

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NON PATENT LITERATURE DOCUMENTS			
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EAL	? 412.	KIM et al., "Control of Optical Transmission Through Metals Perforated With Subwavelength Hole Arrays," Optic Letters vol. 24, No. 4, pp. 256-257, (Feb. 1999).	
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	423.	PCT/US02/13442, Search Report 9/13/02	
	424.	PCT/US04/20330 Search Report 11/8/2004	
	425.	PCT/US05/029821 International Search Report (12/27/05)	
	426.	PCT/US05/030927 International Search Report (0125/2006)	
	427.	PCT/US05/031693 International Search Report	
	428.	PCT/US05/032231 International Search Report (4/7/2006)	
	429.	PCT/US05/033558 Partial International Search Report (02/24/06)	
EAL	430.	PCT/US2004/035820 International Search Report and Written Opinion (04.11.2005)	

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SHEET 15 OF 15	Attorney Docket No.	QCO.087A / 061119

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EAL	431.	PCT/US96/17731 Search Report	
	432.	RALEY et al., "A Fabry-Perot Microinterferometer for Visible Wavelengths," IEEE Solid-State Sensor and Actuator Workshop, Jun. 1992, Hilton Head, SC.	
	433.	SCHNAKENBERG et al., "TMAHW Etchants for Silicon Micromachining," 1991 International Conference on Solid State Sensors and Actuators-Digest of Technical Papers, pp. 815-818 (1991).	
	434.	SPERGER et al., "High Performance Patterned All-Dielectric Interference Colour Filter for Display Applications," SID Digest, pp. 81-83, (1994).	
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EAL	442.	ZHOU et al., "Waveguide Panel Display Using Electromechanical Spatial Modulators" SID Digest, vol. XXIX, (1998).	

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